



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Yasunori Ito, et al.

Serial No.: 10/640,850

Filed: August 13, 2003

For: METHOD OF PRODUCING  
CERAMIC THERMISTOR  
CHIPS

Group Art Unit: 1742

Examiner: H. D. Wilkins III

Attorney Docket: MURT P083D1

**CERTIFICATE OF MAILING**

Date of Deposit: April 24, 2006

I hereby certify that this correspondence is, on the date shown above, being:

deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, Alexandria, Virginia 22313.

Typed or printed name of person mailing:

Deborah Neill

*Deborah Neill*

Signature of person mailing

**AMENDMENT "A"**

Commissioner for Patents  
Alexandria, Virginia 22313

Sir:

In response to the Office Action dated December 6, 2005 in the above-referenced application, regarding which it is requested with the payment of a fee to extend the period for response by two months to May 6, 2006, applicant amends the application as follows: